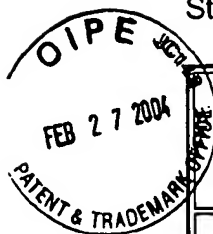


ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0



Title of
Invention

**ELECTRON OPTICS FOR MULTI-BEAM ELECTRON
BEAM LITHOGRAPHY TOOL**

Application Number: 10/630349



Confirmation Number: 9297

First Named Applicant: N. PARKER

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Search string: (6509750 or 6465783 or 6252412 or 6157039
or 6023060 or 5981962 or 5892224 or 5578821
or 5557105 or 5502306 or 5430292 or 5384463
or 5363021 or 4996441 or 4902898 or 4724328
or 4742234 or 4694178 or 4661709 or 4430571
or 4390789).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
KN	1	6509750	2003-01-21	TALBOT			
VN	2	6465783	2002-10-15	NAKASUJI			
VN	3	6252412	2001-06-26	TALBOT ET AL.			
VN	4	6157039	2000-12-05	MANKOS			
VN	5	6023060	2000-02-08	CHANG ET AL.			
VN	6	5981962	1999-11-09	GROVES ET AL.			
VN	7	5892224	1999-04-06	NAKASUJI			
VN	8	5578821	1996-11-26	MEISBURGER ET AL.			
VN	9	5557105	1996-09-17	HONJO ET AL.			
VN	10	5502306	1996-03-26	MEISBURGER ET AL.			
VN	11	5430292	1995-07-04	HONJO ET AL.			
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LN	16	4724328	1988-02-09	LISCHKE
LN	17	4742234	1988-03-05	FELDMAN ET AL.
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LN	21	4390789	1993-06-28	SMITH ET AL.

Signature

Examiner Name	Date
K. MUYER	06-18-04